



IPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q80777

Akira HATAKEYAMA, et al.

Appln. No.: 10/825,657

Group Art Unit: 1756

Confirmation No.: 5697

Examiner: Shean Chiu WU

Filed: April 16, 2004

For: METHOD FOR FORMING LIQUID CRYSTAL DISPLAY COMPRISING MANUFACTURING
LIGHT-SHIELDING FILM BY APPLYING COATING LIQUID CONTAINING FINE METAL
PARTICLES ONTO SUBSTRATE AND DRYING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is submitted in response to the Office Action dated May 17, 2006.

Review and reconsideration on the merits in view of the following remarks and amendments is respectfully requested.

Please amend the above-identified application as follows on the accompanying pages.

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